

**PATENT**

Docket No.:JCLA8556-D

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of :  
Applicant : JING-HORNG GAU et al.  
Filed : Herewith  
For : VARIABLE CAPACTOR STRUCTURE AND METHOD OF  
MANUFACTURE

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**PRELIMINARY AMENDMENT**

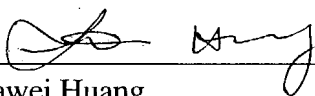
Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Prior to the examination on merits, please amend the above-identified application as shown in the attached sheets. No new matter has added through the amendment. Entry of the amendment is requested.

Respectfully submitted,

Dated: 7/29/2003

By:   
Jiawei Huang  
Registration No. 43,330

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